

Electronic Acknowledgement Receipt

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International Application Number:	
Confirmation Number:	8888
Title of Invention:	METHOD FOR FORMING A CONTACT USING A DUAL DAMASCENE PROCESS IN SEMICONDUCTOR FABRICATION
First Named Inventor/Applicant Name:	In Kyu Chun
Customer Number:	34431
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File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part /.zip	Pages (if appl.)
1		PIA30957_DB_E_US_POA_1 2-20-06.pdf	89557	yes	2

	Multipart Description/PDF files in .zip description		
	Document Description	Start	End
	Power of Attorney	1	1
	Assignee showing of ownership per 37 CFR 3.73(b).	2	2
Warnings:			
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